

Overview of the HERMES reduction pipeline

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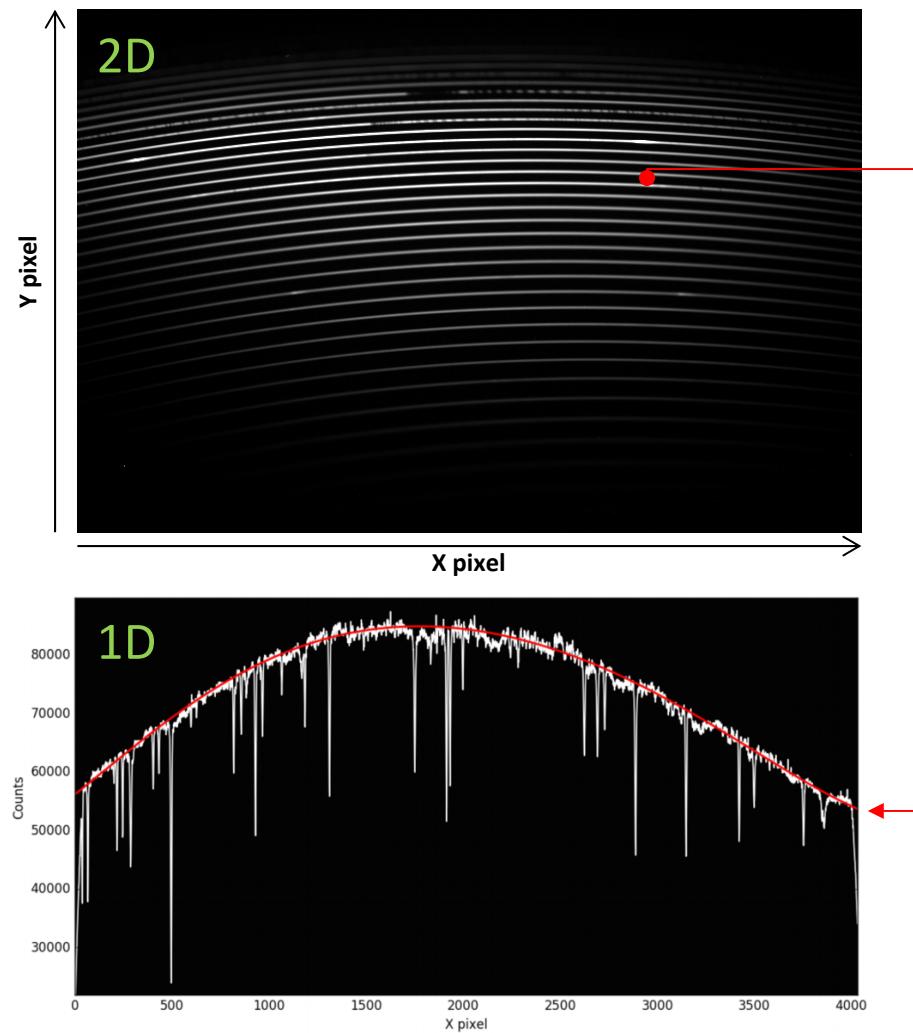
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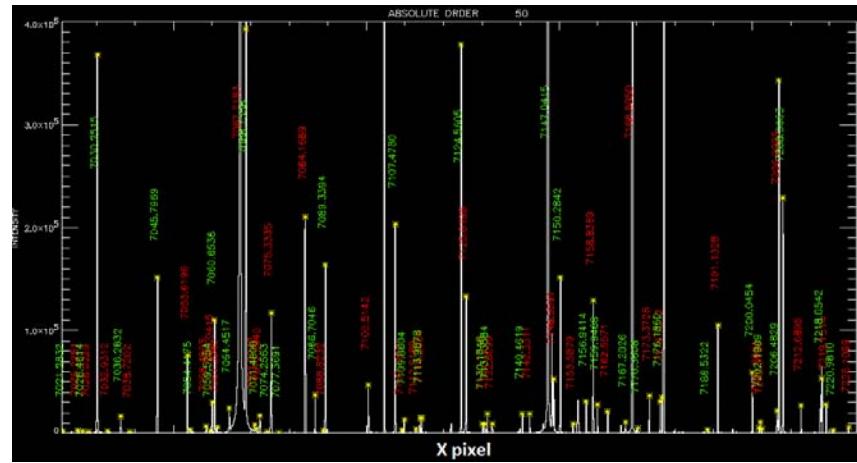
Reduction (1/2)

- Extract the data from the CCD
 - $2D \rightarrow 1D$
 - Needs: order positions, cross-order profile, blaze function ...



Reduction (2/2)

- Data calibration
 - Wavelength and flux calibration
 - Needs: Line identification, observation of standard stars.



Principle: differential

Instrument model

- Calibration data obtained during a night of reference
- Reduced « manually »
- A set of reference frames and numbers.

Observations

- Calibration data obtained during the night
- Science exposures

Principle: differential

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Observations

- Calibration data obtained during the night
- Science exposures

How the system evolved since
the reference night:

- Relative order positions
- Relative spectral line positions

Operations overview

1
absoluteDRS

Spectrum
extraction

2
dispersionDRS

Wavelength
dispersion

3
applyDRS

Apply
calibrations

Calibration

1

absoluteDRS

2

dispersionDRS

3

applyDRS

Spectrum extraction

- 1 • readFITSImage
- 2 • averageImages
- 3 • computeBiasPrescan
- 4 • cutPrescanRegion
- 5 • subtractBiasCCD
- 6 • convertADUtoPhotonUnits
- 7 • estimateOrderPosition
- 8 • searchOrderPositions
- 9 • modelSearchedOrderPositions
- 10 • measureBackground
- 11 • modelBackground
- 12 • extractOrders

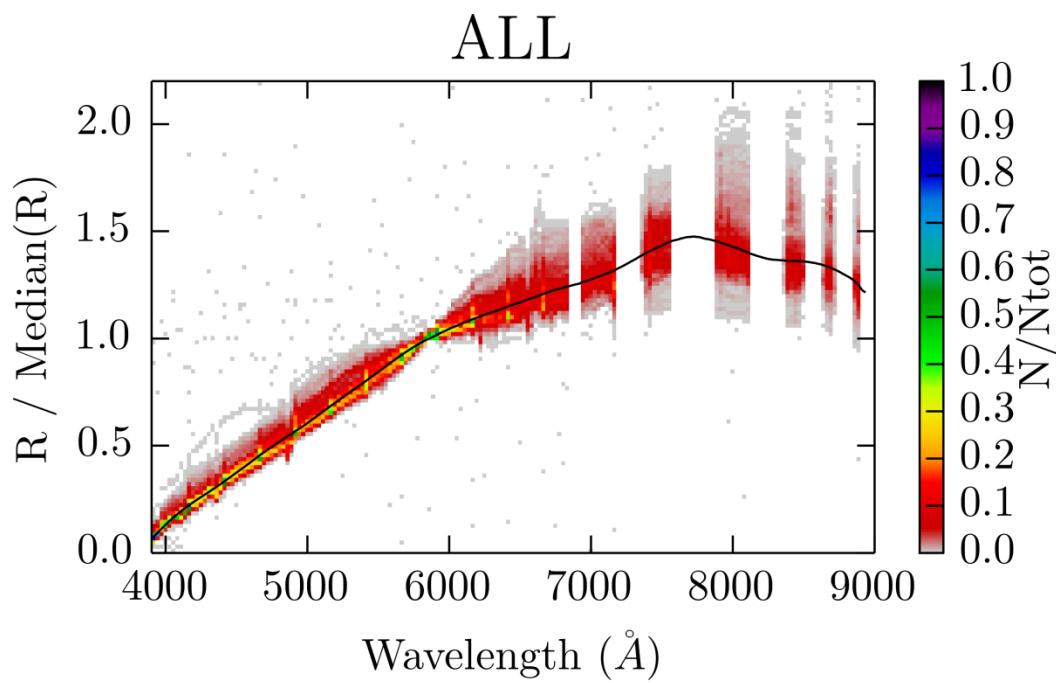
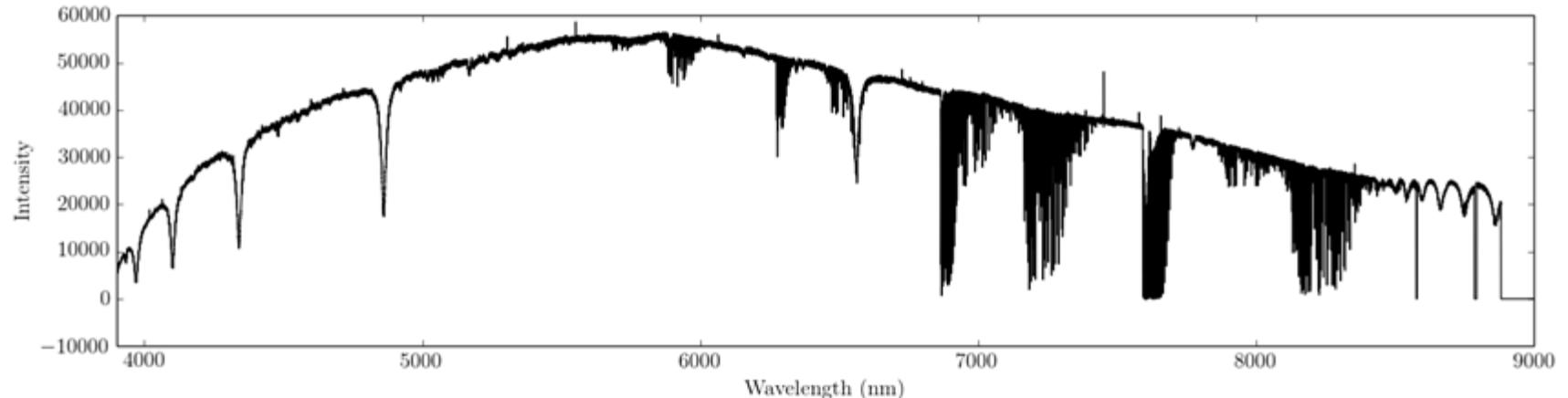
Wavelength dispersion

- 1 • readFITSImage
- 2 • linePositions
- 3 • wlModel
- 4 • computeRadialVelocity

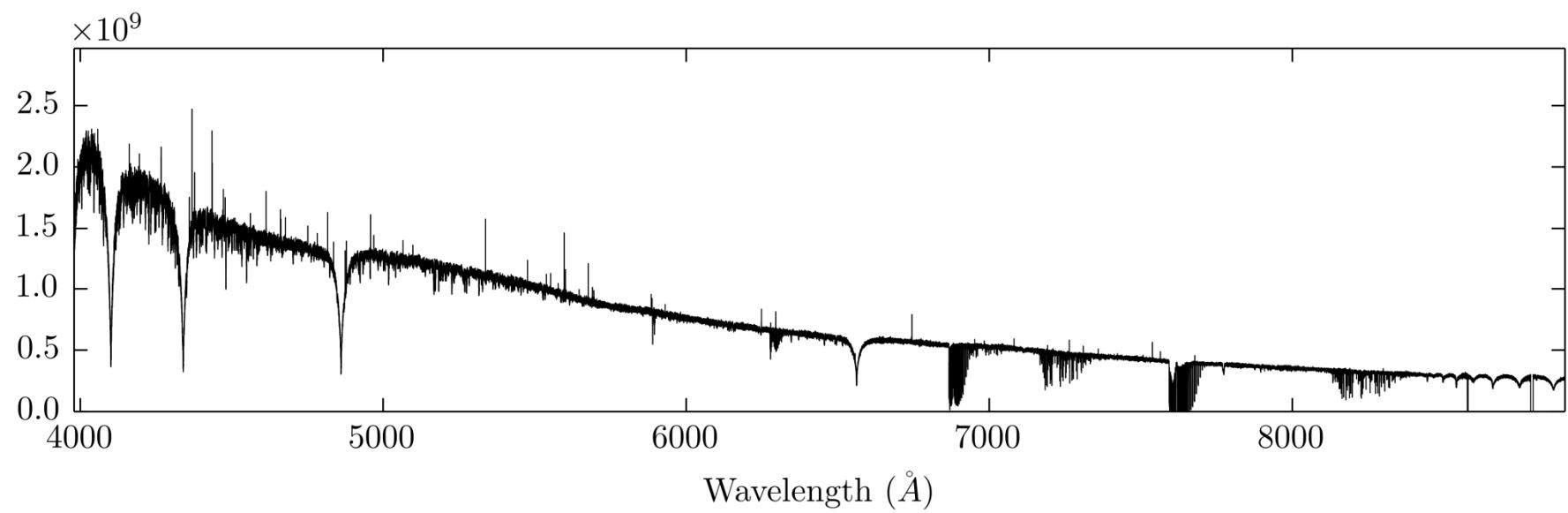
Apply calibrations

- 1 • 1D – FF division
- 2 • rebin
- 3 • merge
- 4 • FF correction

Pipeline product



**mean partial
instrument response**



Conclusion remarks

- Pipeline written in Python (modularity, plotting, mathematical, fits ... public libraries, well documented, but slow).
- Written in a few months. Possibility to adapt it and re-use it for another echelle spectrograph.
- Instrument monitoring is important

Model monitoring

